IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Jiro KONDO, et al.

Serial No. : 10/591,093

Filed : August 29, 2006

For : METHOD FOR REMOVING BORON FROM SILICON

Examiner : Cohen, Stefanie J.

Art Unit : 1793 Confirmation No. : 7884

I hereby certify this correspondence is being electronically transmitted to the United States Patent and Trademark Office via the Office electronic filing system on October 14, 2010

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Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Signature: <u>/Katy Chan-Parsons/</u>
Katy Chan-Parsons

TRANSMITTAL LETTER

SIR:

Transmitted herewith is an Amendment/Response in the above-identified patent application.

[X] No additional fee is required.

The fee has been calculated as shown below.

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	PRESENT NUMBER EXTRA	RATE (\$)	FEE (\$)
TOTAL CLAIMS	15	minus	20	0	52.00	0.00
INDEPENDENT CLAIMS	1	minus	3	0	220.00	0.00
MULTIPLE DEPENDENT CLAIM ADDED				0	390.00	0.00
TOTAL DUE						0.00

[X] The Commissioner is hereby authorized to charge fees under 37 CFR 1.16 and 1.17 which may be required to Deposit Account 11-0600. A duplicate of this paper is enclosed.

Respectfully submitted,

Dated: October 14, 2010 By: /Alan P. Force/

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